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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application Serial No. ....10/071,425  
Filing Date ..... February 8, 2002  
Inventor ..... Terry L. Gilton, et al.  
Assignee ..... Micron Technology, Inc.  
Group Art Unit ..... 2813  
Examiner ..... Pham, Thanhha S.  
Attorney's Docket No. .... MI22-1828  
Title: Semiconductor Processing Method Using Photoresist and an  
Antireflective Coating

RESPONSE TO JULY 7, 2003 OFFICE ACTION

8/6/03  
Am Th

To: Mail Stop Non-Fee Amendment  
Commissioner for Patents  
P. O. Box 1450  
Alexandria, VA 22313-1450

VIA U.S. EXPRESS MAIL

From: Mark Matkin (Tel. 509-624-4276; Fax 509-838-3424)  
Wells St. John P.S.  
601 West First Avenue, Suite 1300  
Spokane, WA 99201-3828

Responsive to the Office Action dated July 7, 2003, Applicant amends  
and remarks as follows:

AMENDMENTS

RECEIVED  
JUL 28 2003  
TECHNOLOGY CENTER 2800

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